Notice of Allowability	Application No.	Applicant(s)
	10/005,592	GAMMEL ET AL.
	Examiner	Art Unit
	Jack I. Berman	2881
The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this or other appropriate communica IGHTS. This application is subje	application. If not included ation will be mailed in due course. THIS
1. X This communication is responsive to the amendment filed	on 18 October 2004.	
2. X The allowed claim(s) is/are <u>1-9,11-18,20-28 and 30-34</u> .	•	
3. X The drawings filed on 26 October 2001 are accepted by the	e Examiner.	÷
<ul> <li>4. Acknowledgment is made of a claim for foreign priority ur</li> <li>a) All b) Some* c) None of the:</li> <li>1. Certified copies of the priority documents have</li> <li>2. Certified copies of the priority documents have</li> <li>3. Copies of the certified copies of the priority documents have</li> <li>International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	been received. been received in Application No	)
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		ply complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give		
<ol> <li>CORRECTED DRAWINGS (as "replacement sheets") must</li> <li>(a) including changes required by the Notice of Draftspers</li> <li>1) hereto or 2) to Paper No./Mail Date</li> <li>(b) including changes required by the attached Examiner's Paper No./Mail Date</li> <li>Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the</li> </ol>	on's Patent Drawing Review (Posteria).  S Amendment / Comment or in the dr.  84(c)) should be written on the dr.	ne Office action of awings in the front (not the back) of
<ol> <li>DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT</li> </ol>		
Attachment(s)  1. Notice of References Cited (PTO-892)  2. Notice of Draftperson's Patent Drawing Review (PTO-948)  3. Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date	6. ☐ Interview Summ Paper No./Mail 8), 7. ☑ Examiner's Ame	Date
		JACK BERMAN PRIMARY EXAMINER

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An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mark Superko on November 22, 2004.

The application has been amended as follows:

## IN THE CLAIMS:

16. (Currently Amended) An ion implantation system comprising:

an ion beam source capable of generating an ion beam;

a first dopant gas supply connected to the ion beam source for introducing a dopant gas to the ion beam;

a housing downstream of <u>and proximate to</u> the ion beam source and positioned so that the ion beam passes therethrough; and

a second neutralizing gas supply constructed and arranged to introduce neutralizing gas into a region defined, at least in part by the housing.

- 19. (Canceled)
- 20. (Currently Amended) The ion implantation system of claim 19 16, wherein the housing is upstream of an acceleration/deceleration column for accelerating and decelerating the ion beam to a desired energy.

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The following is an examiner's statement of reasons for allowance: The prior art does not

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teach to supply a neutralizing gas for neutralizing the space charge of an ion beam to a region

adjacent to an ion source in an ion implantation system.

Any comments considered necessary by applicant must be submitted no later than the

payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance."

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Jack I. Berman whose telephone number is (571) 272-2468. The

examiner can normally be reached on M-F (8:30-6:00) with every second Friday off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, John R. Lee can be reached on (571) 272-2477. The fax phone number for the

organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent

Application Information Retrieval (PAIR) system. Status information for published applications

may be obtained from either Private PAIR or Public PAIR. Status information for unpublished

applications is available through Private PAIR only. For more information about the PAIR

system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Jack I. Berman

Primary Examiner

Art Unit 2881

jb

11/22/04